

AMENDMENTS TO THE CLAIMS:

This listing of claims will replace all prior versions, and listings, of claims in the application:

1. (currently amended) An organic film formation apparatus for forming thin film made of an organic ~~matter~~ material on a substrate having a mask for separately painting pixels on an organic film formation surface thereof, said organic film formation apparatus comprising:

a chamber for containing said substrate;

holding means for holding said substrate, said holding means being provided in said chamber;

vaporizing means for vaporizing organic raw material into gas phase to generate raw material gas;

~~carrier gas introducing means for introducing carrier gas and mixing said raw material gas and said carrier gas;~~

raw material gas transportation means for transporting said raw material gas using ~~said~~ a carrier gas;

discharging means for discharging said raw material gas transported by said raw material gas transportation means into said chamber; and

exhausting means for exhausting said chamber,

~~wherein said substrate is deposited within said chamber with said substrate being set in an arrangement selected from an arrangement in which said organic film formation surface of said substrate faces upward in a vertical direction straight up from the ground, an arrangement in which said organic film formation surface of said substrate is put in parallel to the vertical direction, and an arrangement in which said organic film formation surface of said substrate is slanted relative to the vertical direction.~~ the substrate is deposited on said holding means at a location in the chamber within a range such that an angle θ measured from a horizontal axis bisecting said chamber to the location in the chamber satisfies the expression $-60^\circ \leq \theta < 0^\circ$, $0^\circ < \theta \leq 80^\circ$.

2. (canceled)

3. (canceled)

4. (canceled)

5. (canceled)

6. (currently amended) The organic film formation apparatus as claimed in Claim 1, ~~wherein said holding means slides said substrate having said mask for separately painting pixels.~~ further comprising a drive mechanism which slides said holding means.

7. (original) The organic film formation apparatus as claimed in Claim 1, wherein said holding means turns said substrate having said mask for separately painting pixels.

8. (original) The organic film formation apparatus as claimed in Claim 1, wherein said holding means turns to allow said substrate having said mask for separately painting pixels to move around an axis of said holding means.

9. (currently amended) The organic film formation apparatus as claimed in Claim ~~1~~ 6, wherein said holding means turns said substrate having said mask for separately painting pixels while ~~sliding said substrate.~~ said drive mechanism slides said holding means.

10. (original) The organic film formation apparatus as claimed in Claim 1, wherein said holding means includes cooling means for cooling a back face of said substrate having said mask for separately painting pixels.

11 – 30. (canceled)